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PATENT

Attorney Docket :
033082 M 295

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Youngchul PARK, et al.
Serial No.: 10/561,976 Art Unit: 4122
Filed: December 22, 2005 Examiner: Not Yet Assigned
For: HEAT TREATMENT APPARATUS AND METHOD OF CALIBRATING
THE APPARATUS

FOURTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) and copies of the documents cited therein. The documents are cited on accompanying Supplementary European Search Report issued in corresponding application EP 04 74 6795.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application.

Further, Applicants certify under 37 C.F.R. 1.97(e)(1) that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
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